

<b>Notice of References Cited</b>	Application/Control No. 10/676,972	Applicant(s)/Patent Under Reexamination SAID ET AL.	
	Examiner Martin J. Angebrannt	Art Unit 1756	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,768,850	07-2004	Dugan et al.	385/124
*	B	US-6,555,781	04-2003	Ngoi et al.	219/121.67
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	01/09899	02-2001	WIPO	Borrelli et al.	**
	O	99/55487	11-1999	WIPO	Stuart et al.	***
	P					
	Q					
	R					
	S					
	I					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Hirao et al. "Writing waveguides and gratings in silica and related materials by a femtosecond laser", J. Noncryst. Sol. Vol. 239 pp. 91-95 (1998)
	V	Davis et al., "Writing waveguides in glass with a femtosecond laser, Opt. Lett., Vol. 21(21) pp. 1729-1731 (11/1996)
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.